

Metropolitan Water Reclamation District of Greater Chicago

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January 22, 2018

TO: Satellite Entities Owning/Operating Separate Sanitary Sewer Systems in the Metropolitan Water Reclamation District of Greater Chicago (District)

**SUBJECT: Infiltration and Inflow Control Program (IICP)
 2017 Annual Summary Report
 2017 Annual Status Report, Volume No. 2**

Satellite Entity 2017 IICP Annual Summary Report due March 1, 2018

The purpose of the IICP, defined in Article 8 of the Watershed Management Ordinance (WMO), is to reduce sanitary sewer overflows and basement backups, comply with the NPDES permit requirements for the District’s Water Reclamation Plants, and to minimize extraneous flows transported to the District’s facilities. To achieve these goals, satellite entities that own or operate sanitary sewer systems discharging into the District’s facilities are required to identify and address I/I sources within their public and private sewer systems.

The IICP requires each satellite entity to submit an annual report on their progress and plans relative to the Short Term Requirements and Long Term Operation & Maintenance Program. Please submit a completed Annual Summary Report, along with the appropriate attachments, by March 1, 2018. The submittal can be emailed to mwrddi@mwrdd.org or mailed to:

Mr. Adam Witek, P.E.
 Senior Civil Engineer
 Metropolitan Water Reclamation District of Greater Chicago
 111 E. Erie Street, 6th Floor
 Chicago, IL 60611

District’s 2017 IICP Annual Status Report, Volume No. 2

This Report provides status of all satellite entities working with the District to meet the IICP requirements and is available to view on our IICP website.

The IICP, Technical Guidance Manual, reporting forms, and other I/I resources are also available on our IICP website at ii.mwrdd.org. Please contact Mr. Witek at (312) 751-4449, if you have any questions.

Very truly yours,



David St. Pierre